



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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10/10/01
10/C

In re application of

Masamichi NAKASHIBA et al. : Docket No. 2000_0722

Serial No. 09/589,388 : Group Art Unit 3723

Filed June 8, 2000 : Examiner G. Nguyen

APPARATUS FOR AND METHOD FOR
POLISHING WORKPIECE

1331 U.S. PAT. & T. OFFICE
NO. 6,267,333 AUTHORIZED
BY GOVT. 1331 DIVISION IN THE
NAME OF THE APPLICANT TO DEPOSIT
REG. NO. 23-0975.

SUPPLEMENTAL AMENDMENT

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

Further to the Amendment filed September 21, 2001, kindly amend the application as follows:

IN THE CLAIMS:

Kindly amend claim 76 as follows:

~~44~~ 76 (Amended) A polishing apparatus according to claim 73, wherein said central area and said outer circumferential area are formed by chambers formed in said top ring.

41
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26